State Variable Equations

$$\varepsilon_{ij} = \varepsilon_{ij}^{E} + \int_{0}^{t} \dot{\varepsilon}_{ij}^{I} d\tau + \varepsilon_{ij}^{TH} \qquad Kinematic$$

$$\dot{\varepsilon}_{ij}^{I} = \left| \dot{\varepsilon}_{0}^{I} \left(\sigma_{kl}, T, P, f_{p}, \varsigma_{r}, \ldots \right) \right|_{ij} \qquad Kinetic$$

$$\varsigma_{m} = \varsigma_{m} \left(\dot{\varepsilon}_{ij}^{I}, \sigma_{kl}, P, T, f_{p}, \varsigma_{s}, \ldots \right) \qquad Evolution$$

Stouffer and Dame, "Inelastic deformation of metals", 1996

Apparent (Empirical) **Activation Parameters** $\dot{\varepsilon} = \dot{\varepsilon}_o \sigma^n \exp(-\frac{\Delta H}{\rho \tau})$ $n = \frac{\partial \ln \dot{\varepsilon}}{\partial \ln \sigma} \bigg|_{\tau P}$ Stress exponent $V^* \triangleq \frac{\partial \ln \dot{\varepsilon}}{\partial P}\Big|_{\tau_{\tau}}$ Activation Volume $H^* \triangleq \frac{\partial \ln \dot{\varepsilon}}{\partial (1/T)} \Big|_{z=0} \qquad \text{Activation} \begin{cases} \text{Energy} \\ \text{Enthalpy} \end{cases}$ $A^* \triangleq \frac{1}{b} \frac{\partial \ln \dot{\varepsilon}}{\partial (\sigma)} \bigg|_{DT} \qquad \text{Activation} \begin{cases} \text{Volume} \\ \text{Area} \end{cases}$

Orowan's Equation (Kinetic Equation)



Egon Orowan 1966 as a Visiting Scientist at the Boeing Scientific Research Laboratory in Seattle, Washington.

Generation

Recovery

Recrystallization

 $\dot{\varepsilon} = \rho_m |\mathbf{b}| \mathbf{v}$

Lattice Friction

Precipitates

Dislocation Interactions

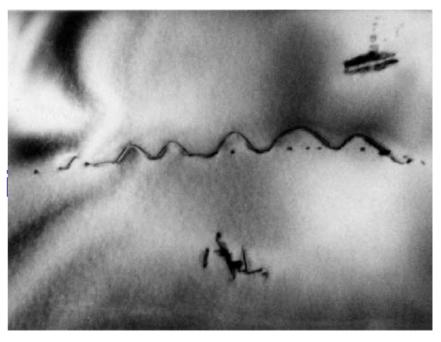
Source/Sink

Frank-Read Source

• Force balance gives

$$\sigma = \frac{\mu b}{2R}$$

• The dislocation density $L = \rho^{-1/2}$



• Then

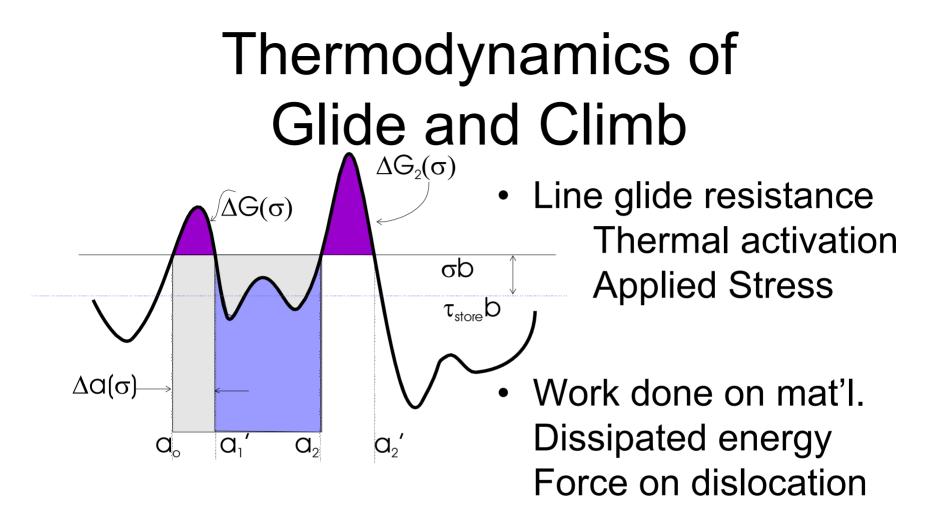
$$\sigma_{crit} = \frac{\mu b \rho^{1/2}}{2}$$

Work Hardening and
Recovery

$$\frac{d\sigma}{dt} = \frac{d}{dt} \Big[\sigma \big(\varepsilon(t), t \big) \Big] = \frac{\partial \sigma}{\partial \varepsilon} \Big|_{t} \dot{\varepsilon} + \frac{\partial \sigma}{\partial t} \Big|_{\varepsilon}$$

$$\frac{d\sigma}{dt} = h\dot{\varepsilon} + r \quad \text{Bailey-Orowan Eq.}$$

- At steady state, hardening = recovery
- If square root of disl. dens. proportional to mean free path, $\lambda = a\rho^{1/2}$ and if density is a function of stress $\sigma^2 = \alpha \mu b \rho^{1/2}$ then can show that $\frac{h}{\mu} = \frac{\alpha}{a}$
- Qtz Olivine W FCC Easy Glide
 1 1-3 50 350 10⁴



Kochs et al., 1975

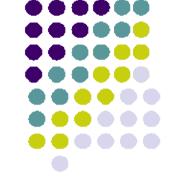
Velocity Kinetics

$$\overline{v} = \frac{\Delta L}{t_g + t_o} \quad \text{where} \begin{cases} \Delta L \text{ is distance to next obstacle} \\ t_g \text{ is time to glide} \\ t_o \text{ is time to overcome obstacle} \end{cases}$$

- If obstacle can be overcome by thermal activation (e.g. lattice friction, cutting of soft ppts., unraveling attractive junctions)
 - $\Box \Delta L >> a_1 a_1' \text{ then } \Delta L = \lambda \text{ (where } \lambda \text{ is the dislocation spacing)}$ $t_g << t_o \text{ e.g. } Cross \ slip \text{ in FCC metals}$
 - $\Box \Delta L \cong a_1 a_1', \text{ obstacle met as soon as overcome,} Glide-controlled Creep$
- Obstacles can't be overcome but may be avoided by climb,

Recovery-controlled Creep

Recovery Processes



- Recovery-removal of defects
 - Recovery processes
 - Collapse of dipoles
 - Loop collapse
 - Annihilation
 - Sub-grain boundary annihilation
 - Climb and glide to grain boundary, surface
 - Sub-grain boundary coarsening
- Recrystallization-creation and motion of high angle grain boundaries
 - Recrystallization Processes
 - Grain growth
 - Static recrystallization
 - Dynamic recrystallization
 - Chemically induced gb migration

Power Law Creep $\dot{\varepsilon} = \varepsilon_{o} \upsilon_{o} \frac{\mu \Omega}{kT} f(\mu_{i})^{p_{i}} \left(\frac{\sigma}{\mu_{shear}}\right)^{n} \exp\left(-\frac{\Delta H}{kT}\right)$

- n combined effect of density and mobility terms
- Fugacity and chemical potential of phases may affect dislocation mobility
- Debye frequency, shear modulus and molecular volume
- For specific models see *Kohlstedt et al.*, and *Al et Kohlstedt* 95.

Competition between Diffusion and Dislocation Creep

• Dislocation Creep:

$$\dot{\varepsilon} = A_{xs}\sigma^2 \exp\left[\frac{Q_{xs}\left[\left(1 - C_{xs}\sigma\right)\right]}{RT}\right]$$

Diffusion Creep

$$\dot{\varepsilon} = A_{diff} \frac{\sigma}{d^m} \cdot \exp\left(-\frac{Q_{diff}}{RT}\right)$$

• Composite Flow (Ter Heege et al.)

$$\dot{\varepsilon} = \dot{\varepsilon}_{cs} V_{cs} + \dot{\varepsilon}_{diff} V_{diff}$$

• State Variable: Grain size

Low Temperature High Stress Laws (Other Creep)

$$\dot{\varepsilon} = \dot{\varepsilon}_{o} \exp\left[-\frac{\Delta g}{kT} \left(1 - \frac{\sigma}{\tau}\right)^{p}\right]^{q}$$